

Title (en)

Method for manufacturing a lithium ion-conductor

Title (de)

Verfahren zur Herstellung eines Lithiumionenleiters

Title (fr)

Procédé de fabrication de conducteur d'ions lithium

Publication

**EP 1431423 A1 20040623 (DE)**

Application

**EP 03026513 A 20031118**

Priority

DE 10259022 A 20021216

Abstract (en)

A solid lithium ion conductor is prepared by shaping and calcining a lithium compound and/or compounds that are converted into this during calcination and in the form of powder having a mean particle size of not more than 5 µm. Preparation of a solid lithium ion conductor having a composition Li<sub>4-x</sub>Si<sub>1-x</sub>P<sub>x</sub>O<sub>4</sub> involves shaping and calcining Li<sub>4-x</sub>Si<sub>1-x</sub>P<sub>x</sub>O<sub>4</sub> and/or compounds that are converted into this during calcination. The Li<sub>4-x</sub>Si<sub>1-x</sub>P<sub>x</sub>O<sub>4</sub> and/or compounds is/are used in the form of powder having a mean particle size of not more than 5 µm. x = at least 0.3 and not more than 0.7.

Abstract (de)

Ein Lithiumionenleiter der Zusammensetzung Li<sub>4-x</sub>Si<sub>1-x</sub>P<sub>x</sub>O<sub>4</sub>, wobei x einen Wert von mindestens 0,3 und höchstens 0,7 hat, wird durch Verformen und Kalzinieren von Li<sub>4-x</sub>Si<sub>1-x</sub>P<sub>x</sub>O<sub>4</sub>, wobei x einen Wert von mindestens 0,3 und höchstens 0,7 hat und/oder von Verbindungen, die sich während der Kalzination dazu umsetzen, hergestellt, wobei das Li<sub>4-x</sub>Si<sub>1-x</sub>P<sub>x</sub>O<sub>4</sub> und/oder die Verbindungen in Form von Pulver mit einer mittleren Partikelgröße von höchstens 5 Mikrometern verwendet werden.

IPC 1-7

**C25C 7/04; C25C 3/02; C22B 26/12**

IPC 8 full level

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CPC (source: EP US)

**C22B 26/12** (2013.01 - EP US); **C25C 3/02** (2013.01 - EP US); **C25C 7/04** (2013.01 - EP US); **Y10T 29/49108** (2015.01 - EP US)

Citation (search report)

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- [AD] US 4042482 A 19770816 - SHANNON ROBERT DAY, et al
- [A] US 4390460 A 19830628 - MIYAUCHI KATSUKI [JP], et al

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**EP 1431423 A1 20040623**; JP 2004196653 A 20040715; US 2004111874 A1 20040617

DOCDB simple family (application)

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